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BIBDATASHEET

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FILING OR 371(c) DATE 11/13/2003 RULE		CLASS 438	GRO	GROUP ART UNIT 2813		ATTORNEY DOCKET NO. CU-3455 RJS	
, Seoul, KOREA, REPU i, Kyoungki-do, KOREA	JBLIC C)F; BLIC OF;					
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KOREA 2003-10704 <u>0</u> 2	2/20/200	3					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/11/2004							
Foreign Priority claimed 35 USC 119 (a-d) conditions yes no Met after Allowance Verified and Acknowledged Examiner's Signature Initials			SHEETS DRAWING 9		TOTAL CLAIMS 10		INDEPENDENT CLAIMS 4
ADDRESS 26530							
TITLE							
Method for reducing poly-depletion in dual gate CMOS fabrication process							
S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:			NT	All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			
	RULE TONS ************************************	DATE 11/13/2003 RULE 7, Seoul, KOREA, REPUBLIC Coi, Kyoungki-do, Korea, Kyoungki-do, Kyoungki-do, Korea, Kyoungki-do,	RULE 11/13/2003 RULE CLASS 438 RULE CLASS 438 CLAS	RULE CLASS 438 GRO A 11/13/2003 RULE CLASS 438 GRO A 38 A 38 GRO A 38 A 38 GRO A 38 GRO A 38 A 38	DATE 11/13/2003	TIONS TIONS TILING LICENSE GRANTED STATE OR COUNTRY KOREA, REPUBLIC OF; Allowance Initials Note of the country of the country of the charge/credit DEPOSIT ACCOUNT for following: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT of time) Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT of 1.18 Fees (1.18 Fees (Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following: CLASS 11/13/2003 438 2813 28